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**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number (country code, no., kind code (if known))	Publication Date	Name of Patentee or Applicant	Pages, columns, lines where relevant passages appear	T
/B.K./	12.	JP 2004-034270	02/05/2004	Il et al.		
↓	13.	JP 2003-073859	03/12/2003	Wada et al.		
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**OTHER DOCUMENTS**

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	16.	Commonly-assigned, co-pending U.S. Patent Application entitled, "Methods and Systems for Single- or Multi-Period Edge Definition Lithography," (Serial No. not yet assigned) (filed September 21, 2005).	
/B.K./	17.	International Search Report and Written Opinion in PCT Application No. PCT/US04/08724 (November 19, 2004).	
/B.K./	18.	International Preliminary Report on Patentability in PCT Application No. PCT/US04/08724 (May 31, 2005).	
/B.K./	19.	International Search Report in PCT Application No. PCT/US04/08725 (February 28, 2005)	

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\*Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.